Advanced MEMS components in closed-loop micro propulsion applications



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SMÖRGÅSBORD [<u>'smœrgəs buːd</u>] MEMS Micropropulsion Components for Small Spacecraft

Thrusters



Pressure Relief Valve



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Flow Control Valves



MEMS Isolation Valve



Filters



Pressure Sensors Presens (N)





MEMS Micropropulsion Components

•First generation MEMS micropropulsion:

- Miniaturised, accurate and open-loop







- Next generation MEMS micropropulsion:
 - Closed-loop control



Xenon flow control module





CubeSat propulsion module





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Motivation - Advanced Nano- and Cube Sats

- Propulsion to enable new missions
 - Drag free flights, Orbit change, FF & RV , docking, de-orbit...
 - -> New scientific results
 - -> Commercial applications
 - -> Space debris mitigation



Challenging requirements

Mission thrust requirements given by CNES for MICROSCOPE		
Thrustrange	1 – 300 μΝ	
Thrust resolution	0.2 μN	
Response time	250 ms	



MICROSCOPE by CNES

Flow Control Requirements for next generation mini Ion engines		
Flow rate range	5 – 50 μg/s	
Flow rate control accuracy	+/- 5% across the flow range	
	+/- 5% above 25 μg/s and +/- 10% below 25 μg/s	
Flow rate control resolution	+/- 0.5 μg/s	



RIT-µX by Astrium



Closed–Loop Flow Control



Integrated mass flow sensor provides control signal to the proportional flow control valve

 \Rightarrow Closed-loop flow control



Thruster chip and front-end electronics

Schematic view of a complete closed -loop control thruster.



Key capabilities – Like any other



Test result of MEMS thruster operating in ON/OFF mode (open loop, using solenoid valve only) to show thrust range. Full thrust can be set in the range **50 micro-Newton** to **5 milli-Newton**



Key capabilities – Unlike any other

Low thrust regime step response: 5µN steps



Test result of a MEMS value operating in closed-loop control mode showing the thrust response to commanded steps of 5 μ N.



Unique performance

Low thrust regime response: 0.1µN steps



Test result of a MEMS value operating in closed loop control mode responding to the commanded steps of 0.1 μ N.



Physics problem

Low flow rates in combination with the wish for fast response



Thruster case: Requirement: 250 ms in response time Flow rate: 5 µg/s

Response time increases linearly with the internal dead volume

Simplified estimate: V ~ 10 mm3

Tubing	Length	Volume
1/8"	5 mm (0.2")	9 mm3
1/4"	0.62 mm (0.025")	10 mm3



The Solution - MEMS

In our view, using <u>MEMS technology</u> and <u>integrating</u> the flow control valve, mass flow sensor and chamber/nozzle on a single chip is the best –if not the only- way to realise a closed-loop control thruster that can meet the challenging requirements with low flow rates in combination with fast response.

Results – Xenon Flow Control



Capable to operate in full flow regime



Results – Xenon Flow Control



Record shattering resolution



Capable to resolve extremely small changes: 0.2 µg/s (200 ng/s)



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Mass Flow [µg/s]

Summary – XeFCM H/W

- Designed, manufactured, and tested a Xenon closed-loop flow control module!
- Mass: 63 grams
- Excellent dynamic range
- Step regulation < 200ng/s
- Fast response time

Next step:

• Testing together with mini Ion engine (Astrium's µN-RIT engine)





Summary – Micro Thruster H/W

- Closed-loop thrust control demonstrated with unique performance (in terms of thrust and response time in the low thrust regime)
- Developing a CubeSat propulsion module
- Four 1mN thrusters with closed-loop thrust control
- Thrust resolution: <10µN
- Propellant: Butane
- Total impulse: 40Ns
- Size: 10*10*3cm
- Mass: 250g
- Operating pressure: 2-5 bar
- Power consumption: 2 W (average, operating)
- Mechanical interface: CubeSat payload I/F (Pumpkin)
- Electrical interface: 52 pins analog (0-12V) and digital (SPI)
 Next step:
 - · Finalise the assembly, integration, and testing





Outlook

- Return to SmallSat in Logan next year for a live demonstration!!!
- Fly our closed-loop products in space



SSC booth 48-49

Swedish coins for size reference...

Thank you for your attention!



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First generation developed for Prisma



Thruster Pod Assembly – Plenty of MEMS inside



 \varnothing = 44 mm (1.73") Four thrusters per pod 10 µN – 1 mN Mass: 115 g





Six-wafer-stack MEMS Thruster Chip



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Physics Lessons

Understanding the physics, an example:

Assume that the MEMS valve is closed. This implies (in vacuum) zero pressure and zero mass flow through the nozzle. Now assume that the valve immediately opens to allow a flow rate of 5µg/s (which corresponds to 2 µN). Also assume that the nozzle throat is sized such that this flow rate corresponds to 0.1 bar pressure in the chamber (which corresponds to thruster dimensioned for ~100 µN at full thrust).

Now, to reach this new steady state condition, the total volume between the valve and the nozzle throat must be "filled up" with gas from zero to 0.1 bar. Assume that the total volume of feed lines and thrust chamber is 10 mm³.

A first order estimate of the **response time of such a system is 230 ms**. Response time increases linearly with volume.

This is an optimistic estimate neglecting a number of effects such as valve opening response, reduced flow rate as the pressure increases, delays in the control loop, etc which in reality will slow down the response time significantly.

However, this example illustrates how crucial it is to minimise the internal volumes in a regulated system with low flow rates.

